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Illyefalvi-Vitez, Z.; Ruzinko, M.; Pinkola, J.

Electronic Components & Technology Conference, 1998. 48th IEEE , 1998

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2 New developments in excimer laser micromachining by image projection

Harvey, E.C.

Microengineering Applications in Optoelectronics, IEE Colloquium on , 1996

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3 Compatibility of common MCM-D dielectrics with scanning laser ablation-via generation processes

Tessier, T.G.; Chandler, G.

Electronic Components and Technology Conference, 1992. Proceedings., 42nd , 1992

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4 Via processing options for MCM-D fabrication: excimer laser ablation vs. reactive ion etching

Tessier, T.G.; Hoffman, W.F.; Stafford, J.W.

Electronic Components and Technology Conference, 1991. Proceedings., 41st , 1991

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5 Patterning of dispenser cathode surfaces to a controlled porosity

Garner, C.E.; Deininger, W.D.; Gibson, J.; Thomas, R.

Electron Devices, IEEE Transactions on , Volume: 36 Issue: 1 Part: 2 , Jan. 1989

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